



IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

Applicant: Cha Deok Dong	.)	I hereby certify that this paper (or fee) is being
Serial No.: 10/720,457)	deposited with the United States Postal Service, first class postage prepaid, addressed to: Commissioner for Patents, P.O. Box 1450,
Filed: November 24, 2003)	Alexandria, VA 22313-1450
For: METHOD FOR FORMING DEVICE ISOLATION FILM IN SEMICONDUCTOR DEVICE)))	September 1, 2005
Group Art Unit: 2822)	\bigcap
Examiner: Michael M. Trihn)))	James P. Zeller Reg. No. 28,491
AMENDMENT "A"		

Commissioner for Patents P.O. Box 1450 Alexandria, VA 22313-1450

Sir:

Please amend the above-identified application as follows:

the amendments to the specification section begins on page 2 of this paper; the amendments to the claims section begins on page 3 of this paper; and the remarks begins on page 9 of this paper.